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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Col	Complete if Known				
Application Number	09/682,329	-			
Filing Date	August 21, 2001				
First Named Inventor	Frank Olschewski				
Art Unit	2624				
Examiner Name	Do, Anh Hong				
Attorney Docket Number	21295.39 (H5236US)				

Examiner	Cite No.1	Document Number	Publication Date	Name of Patentee or	Pages, Columns, Lines, Where
Initials*	No.'	Number-Kind Code ^{2 (F known)}	MM-DD-YYYY	Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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		FORE	IGN PATENT DOCU			
	Cite No.1	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	
A	NO.	Country Code ³ "Number ⁴ "Kind Code ⁹ (if known)				
(1)		DE19902625A1	09-30-1999	Leica Microsystems	GOIJ 3/12	
//		DE4330347A1	03-16-1995	Leica Lasertechnik	GOIT 3/36	
		DE19959184A1	06-15-2000	Shimadzu Corp.	6026 21/50	
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AD		GB2346755	08.16.2000	Shimadzu Corporation		72
	-,	<u> </u>			17	<u>72</u>
Examiner Signature		Auh Do		Date Considered	6/12/03	-

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